



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Gary W. Ferrell et al

U.S. Serial No: 09/ 034,369

Group Art Unit: 3744

Filed: 3 March 1998

Examiner: S. Gravini

Title: "CHEMICAL DRYING AND CLEANING SYSTEM"

Assistant Commissioner for Patents
Washington, D.C. 20231

PETITION FOR CONSIDERATION OF SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Pursuant to M.P.E.P. § 609 and 37 C.F.R. § 1.97, the Applicants request consideration of the accompanying supplemental Information Disclosure Statement, Form 1449, and of the photocopies of the accompanying U.S. Patent No. 5,275,669 and PCT laid-open patent application WO 96/22356 (incomplete), as part of the process of examination of the above-identified patent application. These two references were provided to the Applicants by a third person on or around 1 May 1999 and were not known to the Applicants before that time. The Applicants enclose a check for \$240. for the fee for consideration of this supplemental Information Disclosure Statement.

06/21/1999 NHASSANI 00000001 09034369

01 FC:126

240.00 OP

Date: 15 June 1999

Respectfully Submitted,

John Schipper
John Schipper

Patent Attorney for Applicant